

Title (en)

Cleaning device and method for glue nozzles

Title (de)

Reinigungseinrichtung und Reinigungsverfahren für Leimaufragdüsen

Title (fr)

Dispositif et procédé de nettoyage pour buses à colle

Publication

EP 1321193 A3 20050119 (DE)

Application

EP 02025430 A 20021115

Priority

DE 10163744 A 20011221

Abstract (en)

[origin: EP1321193A2] The cleaning device is fitted to a packet-making machine with at least one glue application jet (1). There is also a suction device (7, 8, 17), by means of which excess cleaning fluid (16) is sucked away after the glue application jet has been charged with it. The liquid glue (13, 14) and the dissolved impurities are sucked away from a region (20) in the vicinity of the jet.

IPC 1-7

B05B 15/02

IPC 8 full level

A24C 5/24 (2006.01); **B05B 15/02** (2006.01); **B05B 15/55** (2018.01); **B05C 11/10** (2006.01); **B05D 3/10** (2006.01); **B05C 5/02** (2006.01)

CPC (source: EP US)

B05B 15/55 (2018.01 - EP US); **B05C 5/02** (2013.01 - EP US)

Citation (search report)

- [X] US 5240745 A 19930831 - YAMAMOTO TOHRU [JP], et al
- [X] DE 2854325 A1 19800619 - MUELLER ERNST & CO
- [A] EP 0951945 A1 19991027 - ABB KK [JP]
- [A] EP 0375263 A2 19900627 - PHILIP MORRIS [US]
- [A] GB 2311475 A 19971001 - TRISK EDWIN SYSTEMS LTD [GB]
- [X] PATENT ABSTRACTS OF JAPAN vol. 2000, no. 25 12 April 2001 (2001-04-12)

Cited by

DE102011086796A1

Designated contracting state (EPC)

AT BE BG CH CY CZ DE DK EE ES FI FR GB GR IE IT LI LU MC NL PT SE SK TR

DOCDB simple family (publication)

EP 1321193 A2 20030625; EP 1321193 A3 20050119; CN 1445027 A 20031001; DE 10163744 A1 20030703; JP 2003211074 A 20030729; PL 357804 A1 20030630; US 2003127530 A1 20030710

DOCDB simple family (application)

EP 02025430 A 20021115; CN 02157587 A 20021220; DE 10163744 A 20011221; JP 2002368054 A 20021219; PL 35780402 A 20021216; US 32279802 A 20021219